

[illegible]

Inventor One Given Name::	Satoshi
Family Name::	TAKANO
Name Suffix::	
City of Residence::	Nakano-ku
State or Prov. of Residence::	Tokyo
Country of Residence::	Japan

Correspondence Information

```
Correspondence Customer Number:: 25944
Name Line One:: Oliff & Berridge PLC
Address Line One:: P.O. Box 19928
City:: Alexandria
State or Province:: VA
Postal or Zip Code:: 22320
Telephone:: (703) 836-6400
Fax:: (703) 836-2787
Electronic Mail:: commcenter@oliff.com
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Application Information

Title Line One::	SEMICONDUCTOR MANUFACTURING METHOD,
Title Line Two::	SUBSTRATE PROCESSING METHOD, AND
Title Line Three::	SEMICONDUCTOR MANUFACTURING
Title Line Four::	APPARATUS
Total Drawing Sheets::	7
Docket Number::	109107

Prior Foreign Applications

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Foreign Application One:: 2000-91642
Filing Date::           March 29, 2000
Country::                Japan
Priority Claimed::       Yes
Foreign Application Two:: 2001-60136
Filing Date::           March 5, 2001
Country::                Japan
Priority Claimed::       Yes
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